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Docket No.: T0203.0008/P008  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Seitaro Matsuo et al.

Application No.: 10/510,479

Confirmation No.: 7443

Filed: October 7, 2004

Art Unit: 2811

For: ECR PLASMA SOURCE AND ECR  
PLASMA DEVICE

Examiner: Not Yet Assigned

REQUEST FOR CORRECTED FILING RECEIPT

Filing Receipt Corrections  
Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicant hereby requests that a corrected Filing Receipt be issued in the above-identified patent application. The official Filing Receipt received by Applicant, a copy of which is attached hereto, has an error in the foreign application.

Please change the filing date from "April 19, 2002" to --April 9, 2002--.

Application No.: 10/510,479

Docket No.: T0203.0008/P008

Applicant additionally requests that all pertinent U.S. Patent and Trademark Office records relating to the subject application be changed to reflect this correction.

Dated: March 29, 2005

Respectfully submitted,

By 

Stephen A. Soffen

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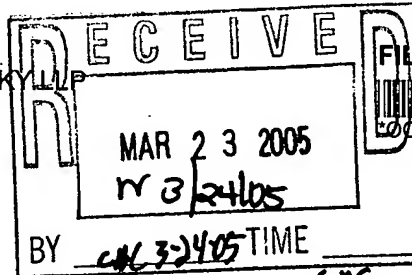
## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/510,479	10/07/2004	2811	950	T0203.0008/P0008	5	12	2

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CONFIRMATION NO. 7443

FILING RECEIPT



\*000000015479224\*

Date Mailed: 03/18/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/04481 04/09/2003

## Foreign Applications

JAPAN 2002-106710 04/10/2002 April 9, 2002

**Projected Publication Date:** 06/23/2005

**Non-Publication Request:** No

**Early Publication Request:** No

## Title

Ecr plasma source and ecr plasma device